# Application/Control No. 10/003,778 Examiner Srilakshmi K. Kumar Applicant(s)/Patent Under Reexamination HENTY, DAVID L. Art Unit Page 1 of 1

# Notice of References Cited

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,854,621	12-1998	Junod et al.	345/158
	В	US-6,025,725	02-2000	Gershenfeld et al.	324/652
	С	US-6,225,981	05-2001	Lu, Ho-Lung	345/164
	D.	US-6,280,327	08-2001	Leifer et al.	463/39
	Ε	US-6,441,804	08-2002	Hsien, Po-Hsun	345/158
	F	US-6,445,379	09-2002	Liu et al.	345/163
	G	US-6,446,154	09-2002	Ajanovic et al.	710/305
	Н	US-6,469,633	10-2002	Wachter, Martin Richard	340/825.69
	-	US-6,380,930	04-2002	Van Ruymbeke, Gilles	345/173
	J	US-			
	K	US-			
	L	US-			
	М	US-			

### **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	Т					

### **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
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	\ \							
	w							
	x							

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